PATENT Customer No. 22,852 Attorney Docket No. 04329.2620-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:)	
Hiroshi NOMURA et al.)	Parent Group Art Unit: 2851
Cont. of Application No.: 09/923,443)	Parent Examiner: D. Esplin
Filed:	Herewith)	
For:	EVALUATION MASK, FOCUS MEASURING METHOD AND ABERRATION MEASURING METHOD)))	
P.O. E	nissioner for Patents Box 1450 ndria, VA 22313-1450		
Sir:			

PRELIMINARY AMENDMENT

Please amend the specification as set forth in this paper.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 11 of this paper.

FINNEGAN HENDERSON FARABOW GARRETT & DUNNERLE

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